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Attorney Docket No.: SAM-0422
Application Serial No.: 10/600,724
Reply to Office Action of: August 20, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Sang-don Yi
Serial No.: 10/600,724
Filing Date: June 20, 2003
Title: SILICON-ON-INSULATOR WAFER AND METHOD OF MANUFACTURING
THE SAME

Examiner: Mai, Anh D.
Group Art Unit: 2814

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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11-18-04

Date

Vanessa Marakas
Vanessa Marakas

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated August 20, 2004, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.